

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of:

Confirmation No.: 6363

Toshihisa NOZAWA, et al.

Group Art Unit: To Be Assigned

International Application No.: PCT/JP 2004/019406 Examiner: To Be Assigned

International Filing Date: December 24, 2004

Serial No.: 10/583,847

Filed: June 21, 2006

For : TEMPERATURE CONTROLLING METHOD FOR SUBSTRATE PROCESSING
SYSTEM AND SUBSTRATE PROCESSING SYSTEM

SECOND INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to the duty of disclosure under 37 C.F.R. 1.56, Applicants are enclosing an Information Disclosure Citation Form (PTO-1449) and a copy of the documents cited therein. This Statement submits document AH that is identified and discussed on pages 1 and 2 of Applicants' specification.

This Statement also submits papers to the PTO from International Application No. PCT/JP2004/019406. The also submitted papers are:

- (1) PCT Notification of Transmittal of Copies of Translation of the International Preliminary Examination Report (PCT/IB/338);
- (2) PCT International Preliminary Report on Patentability (PCT/IB/373); and
- (3) PCT Written Opinion of the International Searching Authority (PCT/ISA/237).

It is respectfully requested that the cited documents be considered by the Examiner in the above-identified patent application and that the cited documents be made officially of record therein. It is further requested that a listing of the same appear on the face of any patent which may issue from this application.

This Information Disclosure Statement is being filed in advance of the receipt of a first Office Action in this application. Therefore, it is believed that no fees are due under 37 C.F.R. Section 1.97(b)(3).

Respectfully submitted,

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By :



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